

Receipt date: 04/27/2005

IPW

Attorney Docket No. P128-US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Jonathan Doan

Art Unit: Not Yet Assigned

Serial No.: 10/766,776

Examiner: Not Yet Assigned

Filed: 1/27/04

For: **PRE-OXIDIZATION OF DEFORMABLE ELEMENTS OF MICROSTRUCTURES**

INFORMATION DISCLOSURE STATEMENT
PURSUANT TO 37 CFR 1.97(b)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-145

Sir:

The attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached PTO Form 1449. Copies of the cited references are enclosed.

No fee or certification is required in connection with this Information Disclosure Statement, since it is being submitted prior to the last of (1) issuance of a first official action on the merits and (2) expiration of the three month period following filing of the above-captioned application.

The above information is presented so that the Patent and Trademark Office can determine any materiality thereof to the claimed invention. It is respectfully requested that the information be considered during the prosecution of this application and that the cited documents be listed on the front page of any patent issuing from this application.

Receipt date: 04/27/2005

The Patent Office is authorized to charge our Deposit Account No. 501516 for any fee which it deems to be required to effect consideration of this statement.

Respectfully submitted,

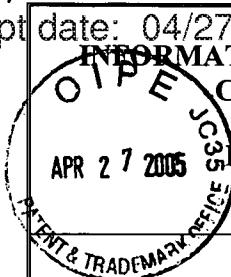


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INFORMATION DISCLOSURE

CITATION

APR 27 2005

PTO-1449

SHEET 1 OF 2

ATTY. DOCKET NO.

P128-US

SERIAL NO.

10/766,776

APPLICANT Doan, et al.

FILING DATE 1/27/04

GROUP Not Yet Assigned

U.S. PATENT DOCUMENTS

EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
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EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
						<input type="checkbox"/>	<input type="checkbox"/>

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

	W. Robert Ashurst, et al., WAFER LEVEL ANTI-STICTION COATINGS FOR MEMS., Sensors and Actuators A 104 (2003), Pgs 213-221.	No date provided	
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	B.C. Bunker, et al., THE IMPACT OF SOLUTION AGGLOMERATION ON THE DEPOSITION OF SELF-ASSEMBLED MONOLAYERS, 2000 American Chemical Society, Pgs 7742-7751.	No date provided	
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EXAMINER	/Shamim Ahmed/ (11/21/2008)	DATE CONSIDERED	11/21/2008

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

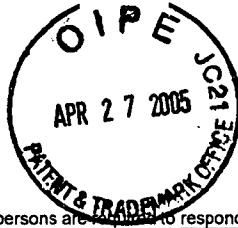
ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /SA/

INFORMATION DISCLOSURE CITATION PTO-1449 SHEET 2 OF 2		ATTY. DOCKET NO. P128-US		SERIAL NO. 10/766,776			
		APPLICANT Doan, et al.					
		FILING DATE 1/27/04		GROUP Not Yet Assigned			
U.S. PATENT DOCUMENTS							
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EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
						<input type="checkbox"/>	<input type="checkbox"/>
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OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)							
EXAMINER	/Shamim Ahmed/ (11/21/2008)		DATE CONSIDERED	11/21/2008			

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Copies of Refs

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